



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 5, 2025	
IGI Report Number	LG754544345
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	10.35 X 7.27 X 4.48 MM

GRADING RESULTS

Carat Weight	2.09 CARATS
Color Grade	E
Clarity Grade	VS 2

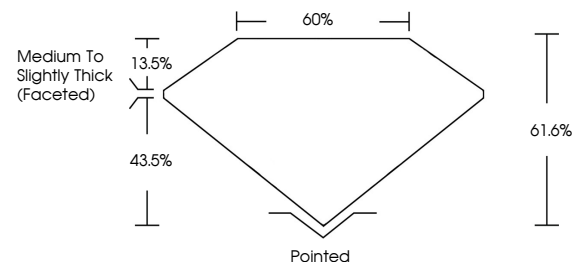
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG754544345

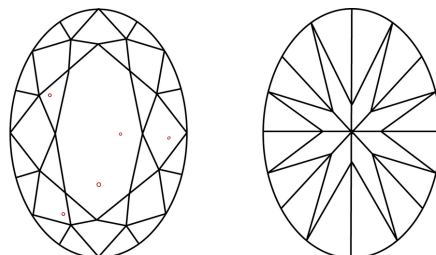
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG754544345
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

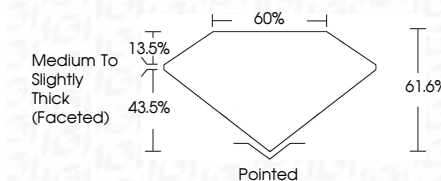
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December 5, 2025
 IGI Report No LG754544345
 COVAL BRILLIANT

0.95 X 7.27 X 4.48 MM	2.09 CARATS	
Carat Weight		
Color Grade		
Clarity Grade		
Depth		
Table		
Girdle		
Culet		
Polish		
Symmetry		
Fluorescence		
Comments		

Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

www.igi.org